

3579 U.S. PTO  
10/080540  
02/25/02

U.S. UTILITY Patent Application

PATENT NUMBER and  
ISSUE DATE

APPL NUM	FILING DATE	CLASS	SUBCLASS	GAU	EXAMINER
10080540	02/25/2002	216	63	1725	

**\*\*APPLICANTS:** Mizumura Michinobu; Fukuyama Ryooji; Ohmoto Yutaka; Watanabe Katsuya;

**\*\*CONTINUING DATA VERIFIED:**

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**\*\* FOREIGN APPLICATIONS VERIFIED:**  
JAPAN 2001-286052 09/20/2001

PG-PUB DO NOT PUBLISH ☐

RESCIND ☐

Foreign priority claimed

☒ yes ☐ no

35 USC 119 conditions met

☒ yes ☐ no

Verified and Acknowledged Examiners's initials

*[Signature]*

ATTORNEY DOCKET NO

500.41254X00

TITLE : Etching method of organic insulating film

U.S. DEPT. OF COM. / PAT. & TM. - PTO-436L (Rev. 12-94)

<b>NOTICE OF ALLOWANCE MAILED</b>		<b>CLAIMS ALLOWED</b>	
		Total Claims	Print Claim for O.G.
<b>ISSUE FEE</b>		<b>DRAWING</b>	
Amount Due	Date Paid	Sheets Drwg.	Figs. Drwg.
			Print Fig.
<input type="checkbox"/> <b>TERMINAL DISCLAIMER</b>		Primary Examiner	
		Prepared for Issue	
		Applicati n Examiner	
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